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Docket No. 8733.154.00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: JANG et al.

GAU: 1765

SERIAL NO: 09/350,313

EXAMINER: R. Kunemund

FILED: July 9, 1999

FOR: METHOD OF CRYSTALLIZING AMORPHOUS SILICON LAYER AND CRYSTALLIZING APPARATUS THEREOF

REQUEST FOR EXTENSION OF TIME
UNDER 37 C.F.R. 1.136

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

It is hereby requested that a 3-month extension of time be granted to 17 September 2001 for

- ☒ filing a response to the Final Official Action dated: 17 May 2001
- ☐ responding to the requirements in the Notice of Allowability dated:
- ☐ filing the Formal Drawings. The Issue Fee due has been timely filed.
- ☐ responding to the Notice to File Missing Parts of Application dated:
- ☐ filing a Notice of Appeal. A timely response to the final rejection, due has been filed.
- ☐ filing an Appeal Brief. A Notice of Appeal was filed on:
- ☐

The required fee of \$110.00 is enclosed herewith by check and any further charges may be made against the Attorney of Record's Deposit Account No. 50-0911. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

LONG ALDRIDGE & NORMAN LLP

John M. Kelly
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Registration No. 33,920

Date: August 20, 2001

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